



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akram et al.

Serial No.: 09/944,499

Filed: August 30, 2001

For: STEREOLITHOGRAPHIC METHOD
AND APPARATUS FOR FABRICATING
STABILIZERS FOR FLIP-CHIP TYPE
SEMICONDUCTOR DEVICES AND
RESULTING STRUCTURES

Examiner: Unknown

Group Art Unit: 2813

Attorney Docket No.: 3936.1US (99-0066.1)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

February 1, 2002

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Deirdra Pfeil

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PRELIMINARY AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.